

_	Application No.	Applicant(s)
	10/059,177	BEIL ET AL.
	Examiner	Art Unit
	John D. Lee	2874

SEARCHED					
Class	Subclass	Date	Examiner		
359	326-332	2/25/2004	JDL		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
USPTO "WEST" Database searched (search strategy on separate sheet)	2/25/2004	JDL		
IEEE XPlore Database searched	2/24/2004	JDL		